

**IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE**

PATENT APPLICATION

Applicant: **Pavel, et al.**

Case: **APPM/7608**

Serial No.: **10/776,672**

Filed: **February 11, 2004**

Examiner: **Tran, Binh X.**

Group Art Unit: **1765**

Confirmation No.: **3482**

Title: **METHOD AND APPARATUS FOR PERFORMING HYDROGEN OPTICAL
EMISSION ENDPOINT DETECTION FOR PHOTORESIST STRIP AND
RESIDUE REMOVAL**

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Commissioner for Patents
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S I R:

RESPONSE TO FINAL OFFICE ACTION DATED FEBRUARY 21, 2007

In response to the Final Office Action dated February 21, 2007 having a shortened statutory period for response set to expire on May 21, 2007, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Applicants believe that no fee is due in connection with this response. However, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 50-3562 for any fees, including excess claim fees or extension of time fees, required to make this response timely and acceptable to the Office.